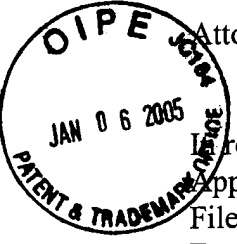


SPW



Attorney's Docket No. 035576/271448

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hamada et al.

Confirmation No.: 5854

Appl. No.: 10/706,600

Filed: 11/12/2003

For: COMPOSITION FOR FORMING POROUS FILM, POROUS FILM  
AND METHOD FOR FORMING THE SAME, INTERLEVEL INSULATOR  
FILM, AND SEMICONDUCTOR DEVICE

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

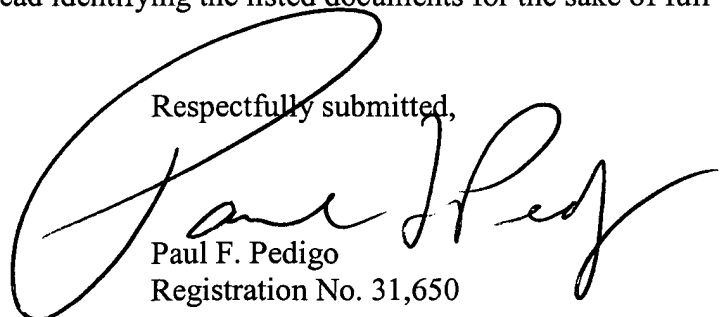
**INFORMATION DISCLOSURE STATEMENT  
CITATION UNDER 37 C.F.R. § 1.97**

Sir:

Attached is a list of documents on form PTO-1449, along with any cited foreign patent documents and non-patent literature documents in accordance with 37 CFR 1.98(a)(2).

It is requested that the Examiner consider these documents and officially make them of record in accordance with the provisions of 37 C.F.R. § 1.97 and Section 609 of the MPEP. By identifying the listed documents, Applicant in no way makes any admission as to the prior art status of the listed documents, but is instead identifying the listed documents for the sake of full disclosure.

Respectfully submitted,

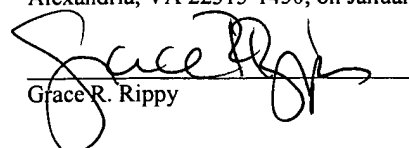


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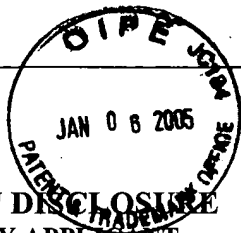
**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on January 4, 2005.

  
Grace R. Rippey

Substitute for form 1449/PTO  
(Revised 04/2003)

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
(Use as many sheets as necessary)



**Complete if Known**

Application Number	10/706,600
Filing Date	11/12/2003
First Named Inventor	Hamada et al.
Group Art Unit	
Examiner Name	
Attorney Docket Number	035576/271448

**U. S. PATENT DOCUMENTS**

Examiner Initials*	Cite No.	Document Number Number - Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages of Relevant Figures Appear

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Foreign Patent Document Country Code - Number Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	English Language Translation Attached
	1	JP 2000-44875	02/15/2000	JSR Corp.	English Abstract	
	2	JP 2001-115028	04/24/2001	JSR Corp.	English Abstract	
	3	JP 2000-309753	11/07/2000	JSR Corp.	English Abstract	
	4	JP 2000-309751	11/07/2000	JSR Corp.	English Abstract	
	5	JP 2001-240798	09/04/2001	JSR Corp.	English Abstract	
	6	EP 1245642	10/02/2002	Samsung Electronics Co., Ltd.	English Abstract	

**OTHER DOCUMENTS**

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	English Language Translation Attached
	7	International Search Report From International Application Number PCT/JP03/14439 Dated December 15, 2003	

Examiner Signature		Date Considered	
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\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.